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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Noriyoshi Matsumoto, et al.
Serial No. : 10/775,683
Filed : February 10, 2004
For : OPTICAL MAGNIFICATION ADJUSTMENT SYSTEM
AND PROJECTION EXPOSURE
Examiner : Rutledge, Della J.
Art Unit : 2851
Attorney
Docket No. : 424P061Div.

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In response to the Office Action dated June 2, 2004, please amend the
above-identified application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

I hereby certify that this correspondence
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P.O. Box 1450, Alexandria, VA 22313-1450

on July 29, 2004 (Date)

Kevin S. Lemack

Name of applicant, assignee, or Registered
Representative

[Signature]
Signature

July 29, 2004
Date